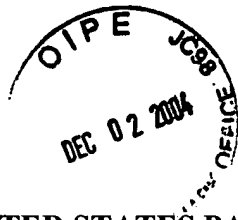


Docket No.: 52775-025



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277  
Masahiro NAKAYAMA, et al. : Confirmation Number: 6895  
Application No.: 10/665,483 : Group Art Unit: 1772  
Filed: September 22, 2003 : Examiner: Alexander S. Thomas

For: NITRIDE SEMICONDUCTOR WAFER AND METHOD OF PROCESSING NITRIDE SEMICONDUCTOR WAFER

LETTER

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the paper filed November 16, 2004 in this application, characterized by the Patent and Trademark Office as a Supplemental Response to Restriction Requirement With Traverse, be disregarded and removed from the file. In response to a telephone call on November 30, 2004 from Examiner Ackun, it was discovered that a clerical error occurred that resulted in the inadvertent filing of that paper in the wrong application. That paper is being filed separately with heading identification for the correct application file. The undersigned is grateful for the courtesy extended by Mr. Ackun.

Respectfully submitted,

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**Date: December 2, 2004**

WDC99 1011996-1.052775.0025

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IFW